EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1372	(324/751,752,719,658).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:36
L2	2580	(438/7,10,16,17).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:36
L3	1461	(204/157.15,157.4,157.41,157.44).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:37
L4	1033	(216/65,66).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:37
L5	4587	(134/1,1.2,1.1,1.3,18).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:37
L6	1461	(204/157.15,157.4,157.41,157.44).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:37
L7	3372	(250/225,559.27,310).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:38
L8	6613	(356/337-343,364,369,445-448,600, 601,612,630).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:38
L9	756	(378/70,89,44).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/12/16 13:38
L10	487	(1 2 3 4 5 6 7 8 9) and ((laser puls$3) near (clean$3 ablat$3 remov$3))	US-PGPUB; USPAT; USOCR	OR	ON	2006/12/16 13:39
L11	356	10 and ((layer film) same (substrate wafer))	US-PGPUB; USPAT; USOCR	OR	ON	2006/12/16 13:43
L12	4995	((laser puls$3) near (clean$3 ablat$3 remov$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/16 13:40
L13	958	12 and ((layer film) same (substrate wafer))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/16 13:40
L14	2	13 and ((layer film) near (measur$4 analys$3 analyz$3 inspect$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/16 13:41

L15	34	13 and ((layer film) same (measur$4 analys$3 analyz$3 inspect$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/16 13:41
L16	2	13 and ((layer film) near (measur$5 analys$3 analyz$3 inspect$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/16 13:42
L17	39	13 and ((layer film) same (measur$5 analys$3 analyz$3 inspect$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/16 13:42